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INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(use as many sheets as necessary)

Complete if Known

Application Number

Filling Date
First Named Inventor

Group Art Unit

Examiner Name

Complete if Known

Application Number

09/938, 411

August 23, 2001

First Named Inventor

Group Art Unit

2834

Examiner Name

T. Dougherty

Attorney Docket Number

U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.1	U.S. PATENT D	COCUMENT Kind Code ² (If known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns Passages or F	Subclass Lines, Where Relevant elevant Figures Appear
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Examiner Initials	Cite No.1	Office ³	Number ⁴	Kind Code⁵ (<i>if known</i>)	Name of Patentee or Applicant of Cited Document	of Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	10
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁵ Applicant is to place a check mark here if English language Translation is attached.

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Complete if Known Substitute for Form 1449B/PTO 09/938,411 **Application Number** INFORMATION DISCLOSURE Filing Date August 23, 2001 STATEMENT BY APPLICANT Wan-Thai Hsu et al. **First Named Inventor** Group Art Unit 2834 (use as many sheets as necessary) Examiner Name Unknown 7. 7 UOM 0210 PUSP// 1899 Sheet Attorney Docket Number 1 OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), Examiner T 2 publisher, city and/or country where published. Cite No.1 Initials C. T.-C. NGUYEN, "Micromachining technologies for miniaturized communication devices, " Proceedings of SPIE: Micromachining and Microfabrication, Sept. 20-22, 1998, pgs. 24-38 T. HIRANO et al., "Design, Fabrication, and Operation of Submicron Gap Comb-Drive Microactuators, " Journal of Microelectromechanical Systems, March 1992, No. 1, pgs. 52-J.R. TUCKER et al., "Nanoscale FETs and STM Lithography," University of Illinois, 1995, pgs. 425-434 C. T.-C. Nguyen, "High-Q Micromechanical Oscillators and Filters For Communications," Int'l Symposium on Circuits and Systems, June 9-12, 1997, pgs. 2825-2828 K. TANAKA, "Nanotechnology towards the $21^{\rm st}$ Century," Thin Solid Films, 1999, pgs. 120-125

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